



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ln re App	lication of:)	
		:	Examiner: N.Y.A.
AKIRA H	IAYAMA)	
	N. 10/600 050	:	Group Art Unit: N.Y.A.
Application	on No.: 10/693,872)	
Filed: October 28, 2003			
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For:	METHOD OF MANUFACTURING	G)	
	AN ENVELOPE AND METHOD	:	
	OF MANUFACTURING AN)	
	ELECTRON BEAM APPARATUS	:	September 9, 2005

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SECOND INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the documents listed, and a copy of the Korean office action citing these documents and its Japanese translation are enclosed.

For the concise statement of relevance of non-English document 2000-133172, the Examiner is respectfully referred to the English abstract attached thereto.

Also, for the concise statement of relevance of non-English document 2000-

323073, the Examiner is respectfully referred to the English abstract attached thereto.

It is respectfully requested that the above information be considered by the

Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such

information has been considered.

Applicant's undersigned attorney may be reached in our New York office by

telephone at (212) 218-2100. All correspondence should continue to be directed to our address

given below.

Respectfully submitted,

Frank A. Del ucia

Attorney for Applicant Registration No. 42,476

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST REFERENCES CITED BY APPLICANT(S) Use several sheets if necessary) SEP 1 2 2005				ATTY DOCKET NO. 03500.017668.			APPLICATION NO. 10/693,872				
				APPLICANT ARIKA HAYAMA							
				FILING DATE October 28, 2003			GROUP NYA				
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INITIAL		DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE			
											
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FOREIGN PATENT DOCUMENTS											
		DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT			
		2000-133172	05/12/00		JAPAN			Abstract			
		2000-323073	11/24/00		JAPAN			Abstract			
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		****	OTHER DOCUMENT(S	(Including Autho	r, Title, Date, Pertinent Pages, Etc.)	,					
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EXAMINER				DATE C	ONSIDERED						

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.